

Search Notes	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/667,980	OSTOJA STARZEWSKI ET AL.
Examiner	Art Unit	
Caixia Lu	1713	

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
526	160	8/10/06	C
	161	1	
	165	1	
	131		
	943		